| m PTO-1595 (Rev. 07/05) OMB No. 0651-0027 (exp. 6/30/2008) | PTO-1595 (Rev. 07/05) No. 0651-0027 (exp. 6/30/2008) 08 - 06 - 2 | | U.S. DEPARTMENT OF COMMERCE United States Patent and Trademark Office | | | |
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| To the Director of the U.S. Pate | To the Director of the U.S. Pate 1034338 | | d documents or the new | address(es) be | elow. | |
| To the Director of the U.S. Pate. 1. Name of conveying party(ies) | | | dress of receiving | | | |
| | Keiichi TANAKA | | Name: SII NanoTechnology Inc. | | | |
| Akikazu ODAWARA Satoshi NAKAYAMA | Akikazu ODAWARA | | Internal Address: | | | |
| Additional name(s) of conveying party(ies) | attached? ☐ Yes 🗹 No | | | | | |
| | 3. Nature of conveyance/Execution Date(s): | | Street Address: 8, Nakase 1-chome, Mihamu-ku, | | | |
| Execution Date(s) July 26, | Execution Date(s) July 26, 2007 | | Chiba-shi | | | |
| ✓ Assignment | Merger | | | | | |
| Security Agreement | Security Agreement Change of Name | | City: Chiba | | | |
| ☐ Joint Research Agreement | ☐ Joint Research Agreement | | | · | | |
| Government Interest Assignment | Government Interest Assignment | | 7in | ; 261-8507 | | |
| Executive Order 9424, Confirm | natory License | Country: JAPAN | | , 201-0307 | | |
| Other | | Additional name(s | s) & address(es) attach | ned? Yes | i ✓ No | |
| 4. Application or patent number | (s): This | | ng filed together with | | -77 | |
| A. Patent Application No.(s) | | B. Patent No | o.(s) | = = | CE (| |
| 11/794,288 | Additional numbers at | tached? Yes | √No | NANCE SEC | OF PUBLIC F | |
| 5. Name and address to whom c | | | er of applications a | nd patents | RF CORI | |
| concerning document should be | | involved:1_ | | <u> </u> | 22 | |
| Name: Bruce L. Adams | | 7. Total fee (37 | CFR 1.21(h) & 3.41 |) \$ 40.00 | C ^A | |
| Internal Address: | | Authorized | to be charged by cr | edit card | | |
| | | ✓ Authorized | to be charged to de | | | |
| Street Address: ADAMS & WILKS | | ✓ Enclosed | ANY DEFICIENCY | IN ENCL | SED | |
| 17 Battery Place - Suite 1231 | | None requ | . FEE ired (government inter | est not affec | ting title) | |
| City: New York | | 8. Payment In | formation | | | |
| | | | a. Credit Card Last 4 Numbers Expiration Date | | | |
| Phone Number: 212-809-3700 | Phone Number: 212-809-3700 | | b. Deposit Account Number 01-0268 | | | |
| Fax Number: 212-809-3704 | Fax Number: 212-809-3704 | | Authorized User Name Bruce L. Adams | | | |
| Email Address: | | Authorize | o User Name <u>Bruce l</u> | Adams | | |
| 9. Signature: | ors L. Go | 45 | Julv | 30, 200 |)7 | |
| 08/03/2007 DBYRNE 00000015 11794288 | Signature | · | | Date | | |
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MAILING CERTIFICATE ON REVERSE SIDE OF PAGE

PATENT

REEL: 019672 FRAME: 0606

ASSIGNMENT

WHEREAS, we, Keiichi TANAKA, Akikazu ODAWARA and Satoshi NAKAYAMA residing at c/o SII NanoTechnology Inc., 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan have invented new and useful improvements in SUPERCONDUCTING X-RAY DETECTOR AND X-RAY ANALYSIS APPARATUS USING THE SAME, for which we have prepared an application for Letters Patent of the United States of America;

AND WHEREAS, SII NanoTechnology Inc., located and doing business at 8, Nakase 1-chome, Mihama-ku, Chiba-shi, Chiba, Japan, is desirous of acquiring an interest therein and in the Letters Patent to be obtained therefor;

NOW, THEREFORE, be it known by all whom it may concern, that for and in consideration of Ten Dollars (\$10.00) and other good and valuable consideration to us in hand paid, the receipt of which is hereby acknowledged, we have assigned, sold and transferred and by these presents do hereby assign, sell and transfer unto the said SII NanoTechnology Inc. for the territory of the United States of America, our entire right, title and interest in and to the said invention, and in and to the said application, prepared and executed by us on <u>JULY 26</u>, <u>2007</u>, filed <u>JUNE 26</u>, <u>2007</u>Serial No. <u>11/794,288</u>, preparatory to obtaining Letters Patent thereon and in and to any and all divisions, reissues and continuations thereof, and in and to any Letters Patent that may be granted thereon; said invention, application and Letters Patent to be held and enjoyed by the said SII NanoTechnology Inc., its legal representatives and assigns, as fully and entirely as the same would have been held by us had this assignment, sale and transfer not been made.

AND, we hereby covenant and agree that we will at any time upon the request and at the expense of said assignee execute and deliver any and all papers and do all lawful acts that may be necessary or desirable to perfect the title to said invention and to obtain Letters Patent therefor, and we hereby authorize and request the Honorable Commissioner of Patents and Trademarks to issue the said Letters Patent to the said SII NanoTechnology Inc. in accordance with this assignment.

Executed this 26th day of <u>JULY</u>, 2007 at _____.

Witness:

Marchi HORI

Akikazu ODAWARA

sarosm rakayuma(L.S.)

Satoshi NAKAYAMA

PATENT
RECORDED: 08/02/2007 REEL: 019672 FRAME: 0607